

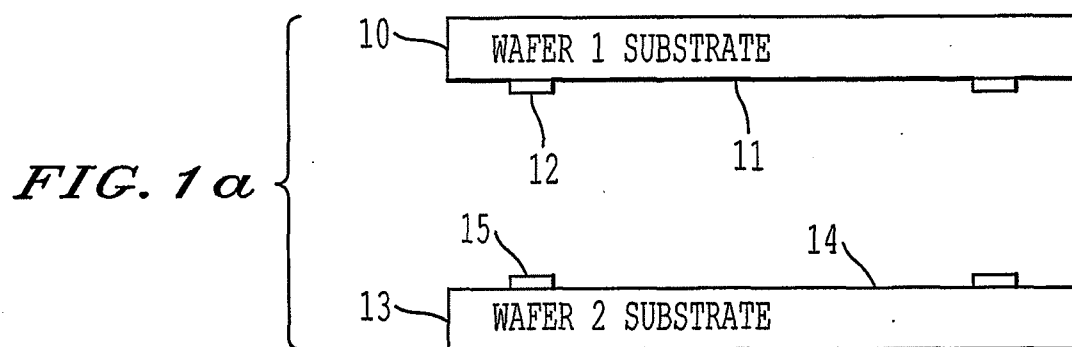


FIG. 1b

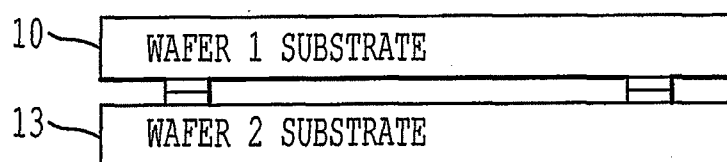


FIG. 1c

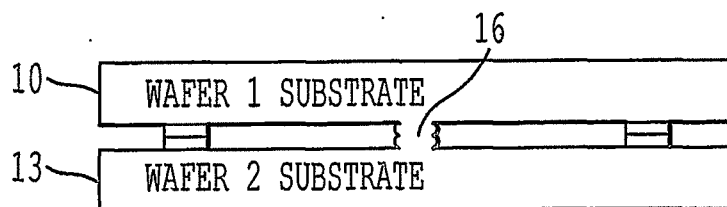
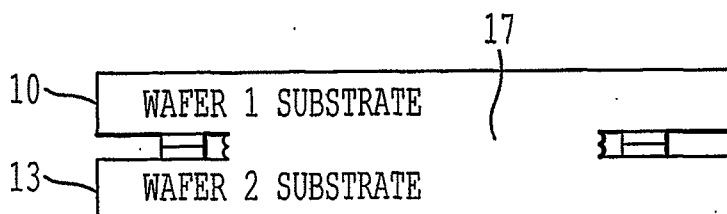


FIG. 1d



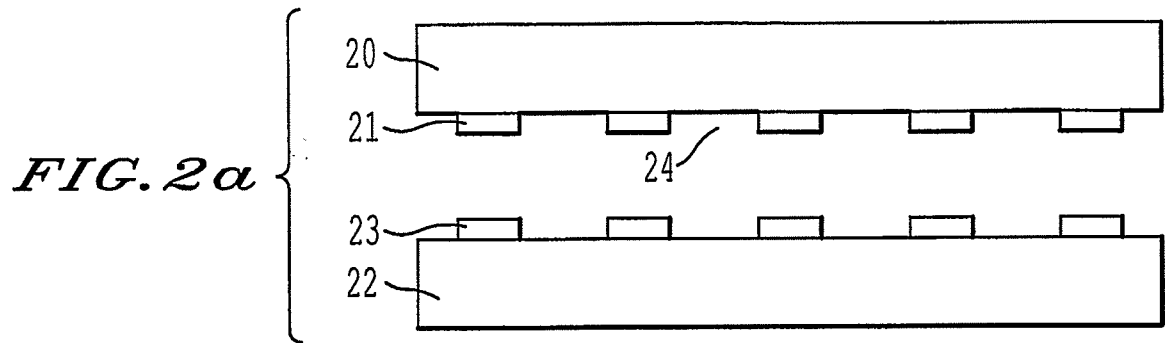


FIG. 2b

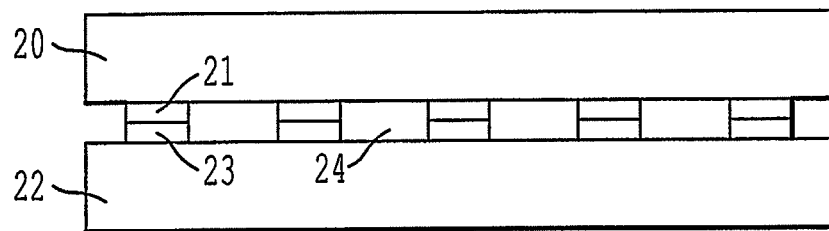


FIG. 2c

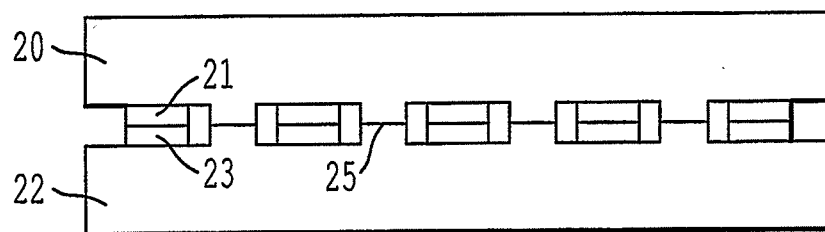


FIG. 4d

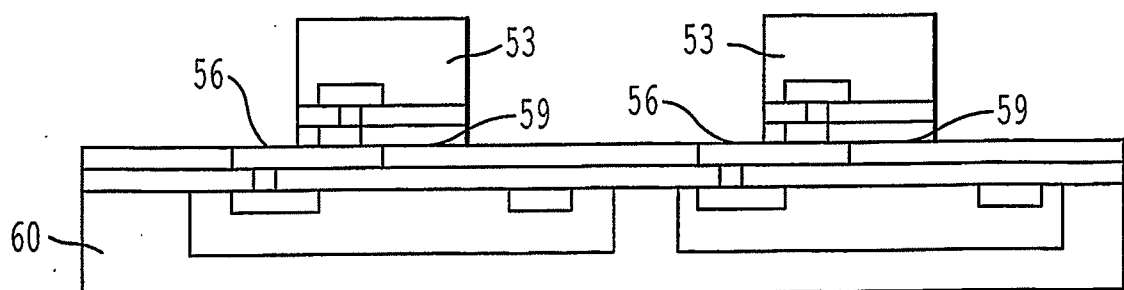


FIG. 2d

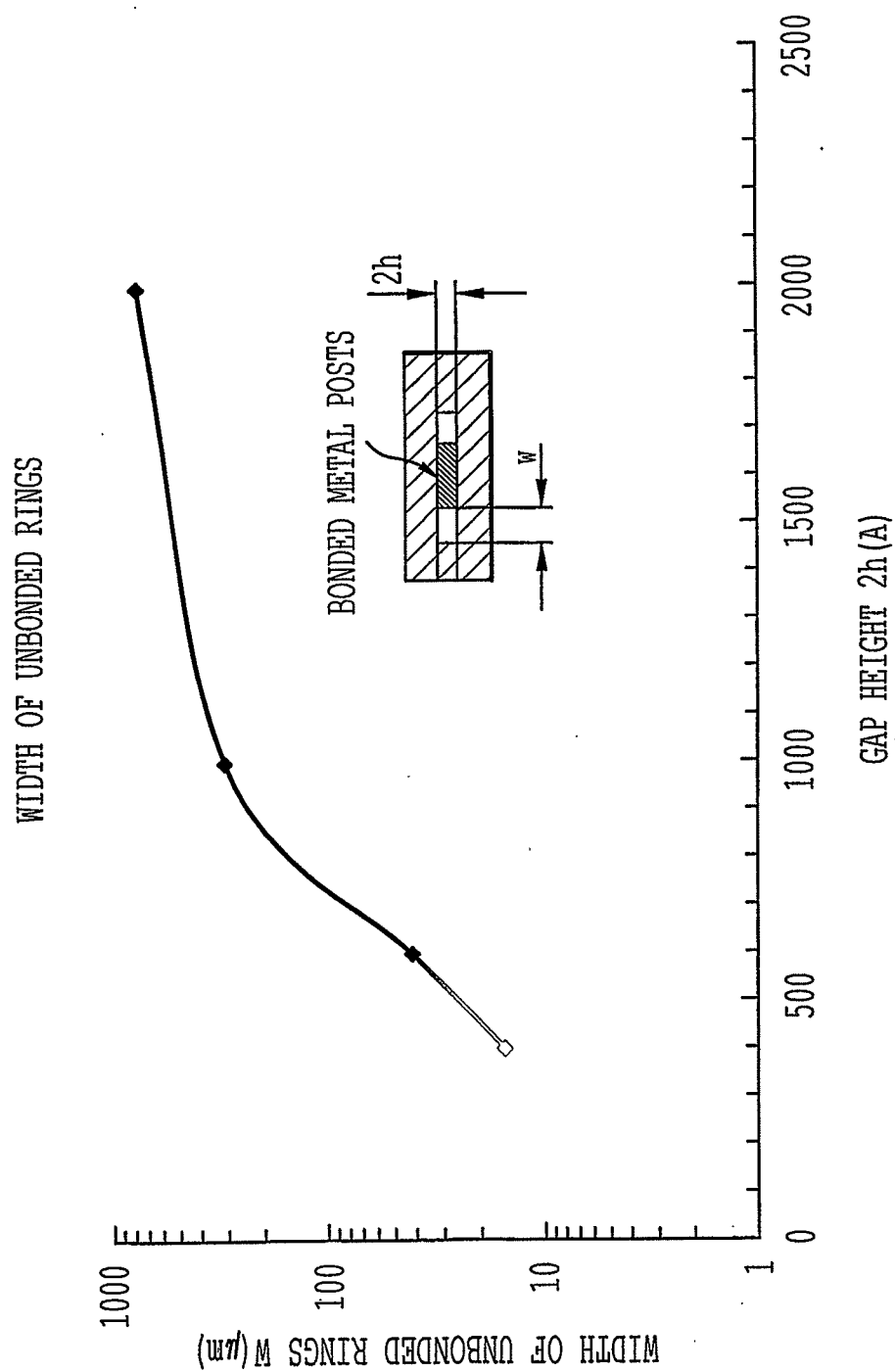


FIG. 3a

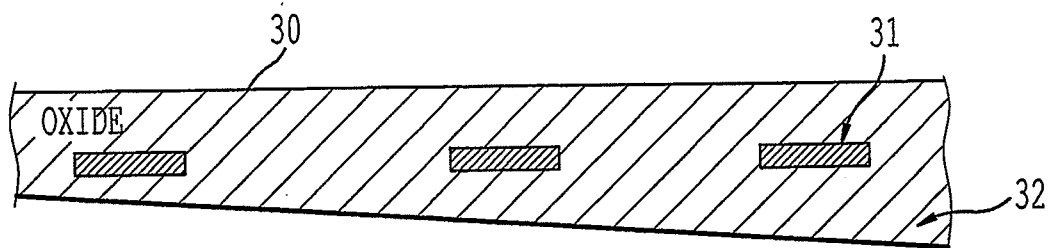


FIG. 3b

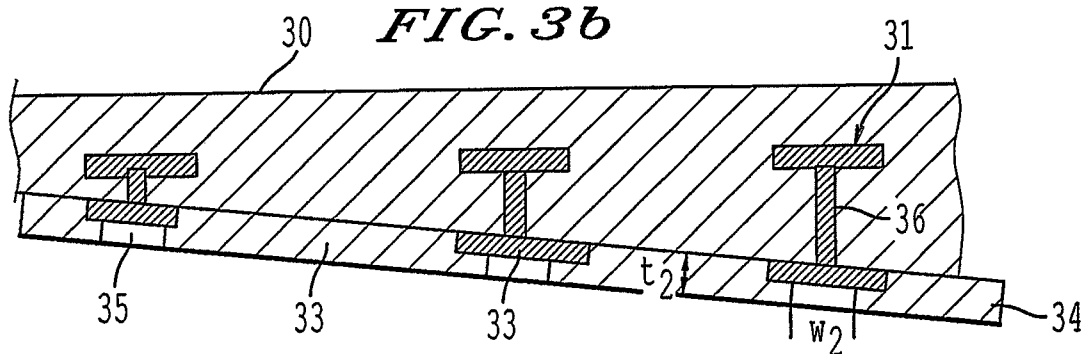


FIG. 3c

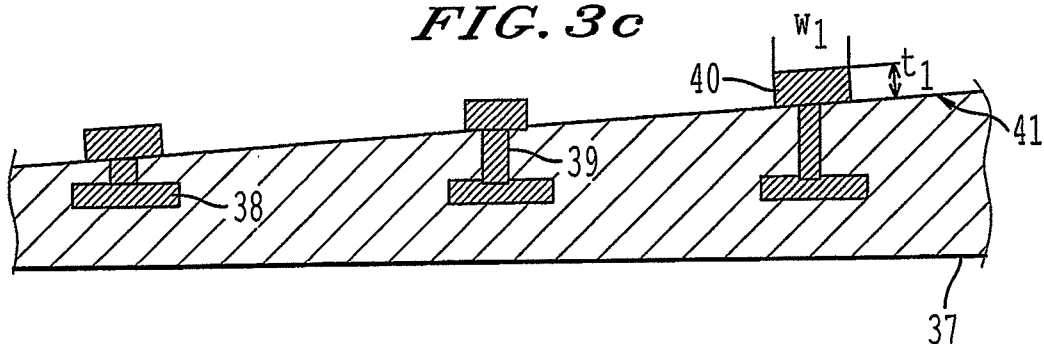
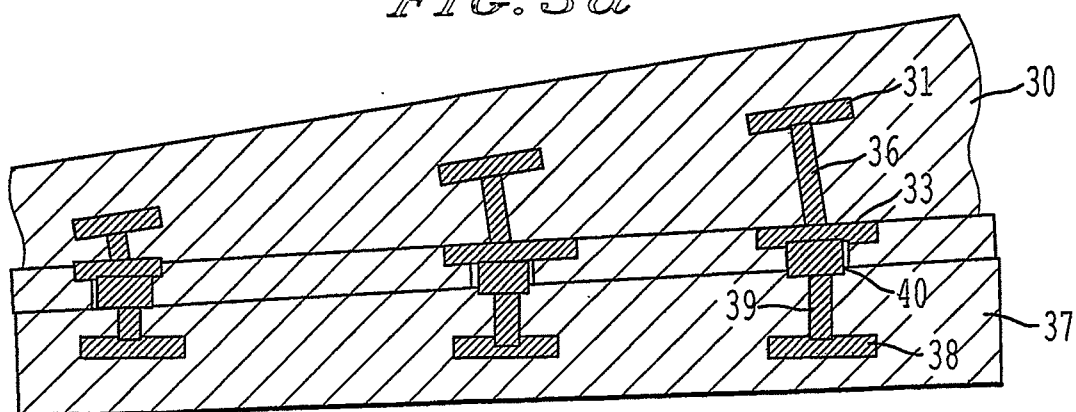


FIG. 3d



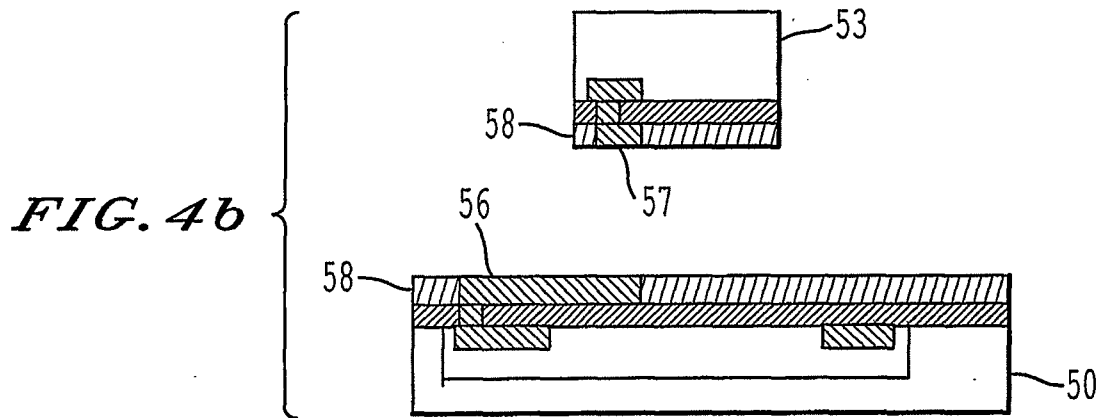
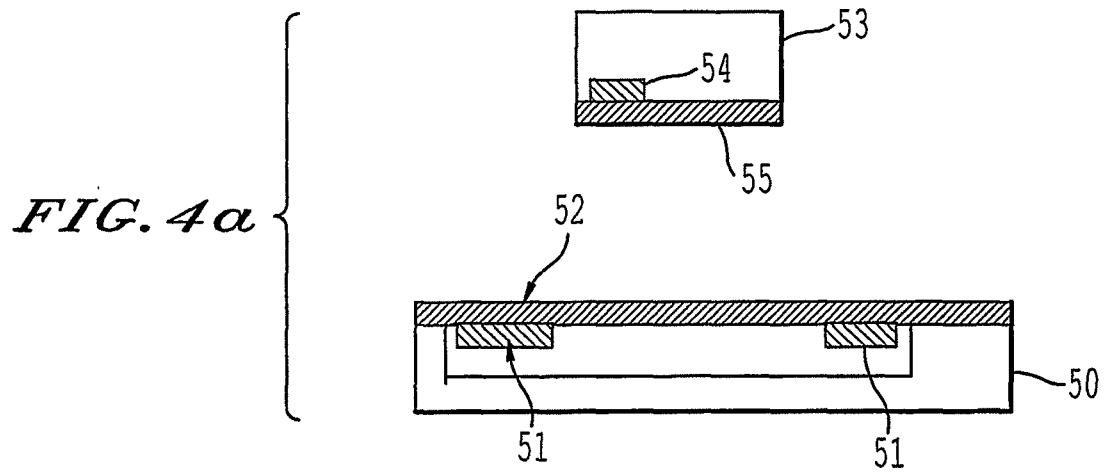


FIG. 4c

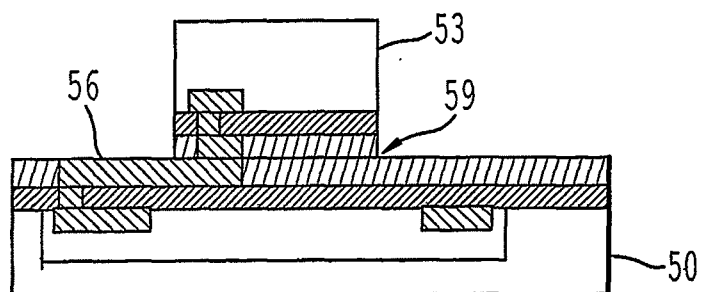


FIG. 5a

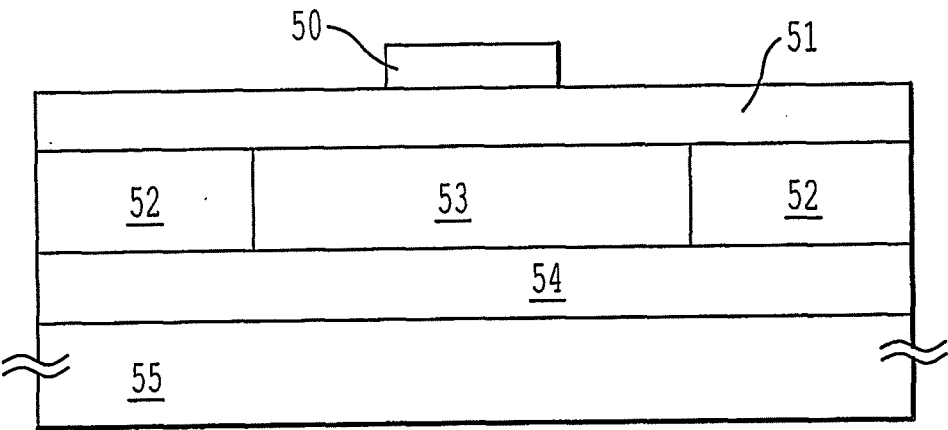


FIG. 5b

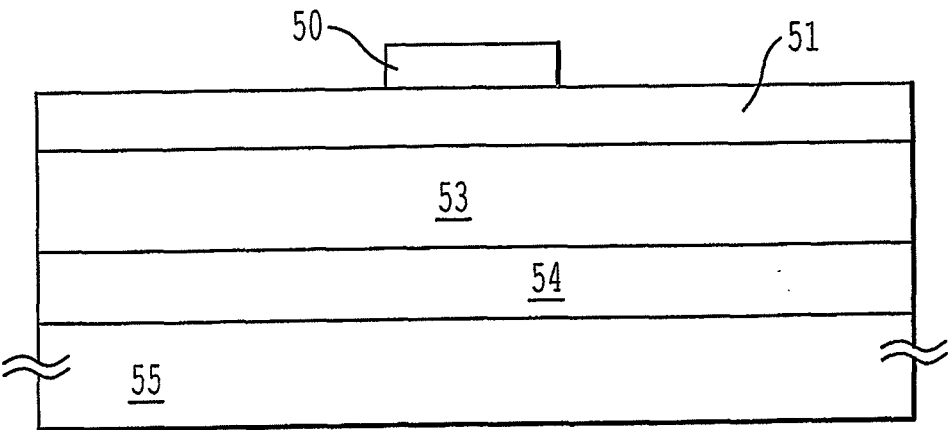


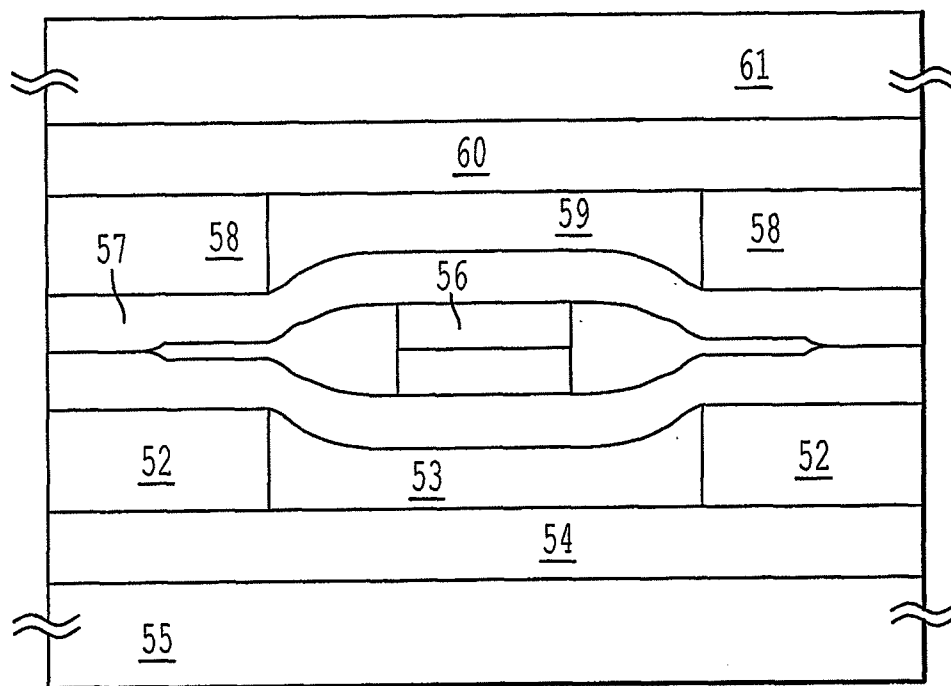
FIG. 5c

FIG. 6a

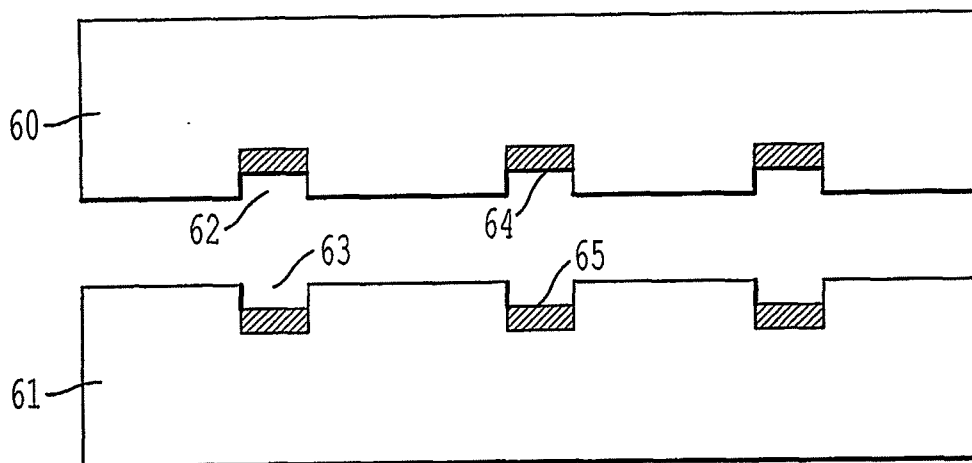


FIG. 6b

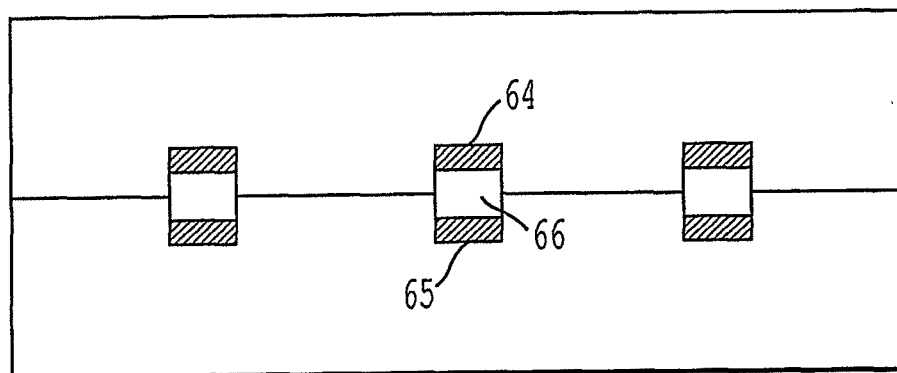


FIG. 6c

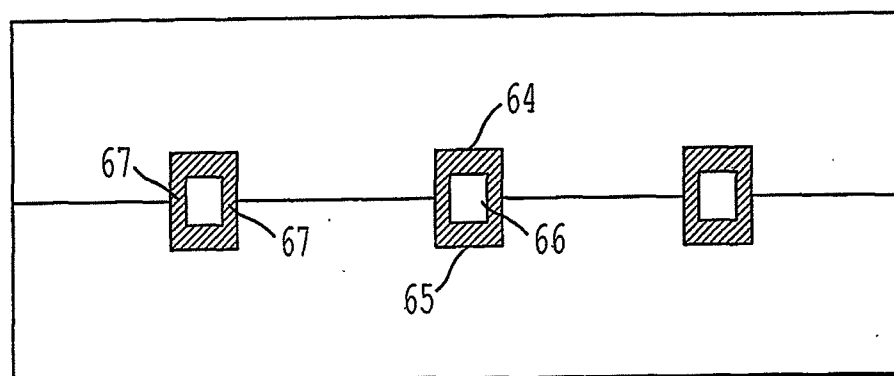
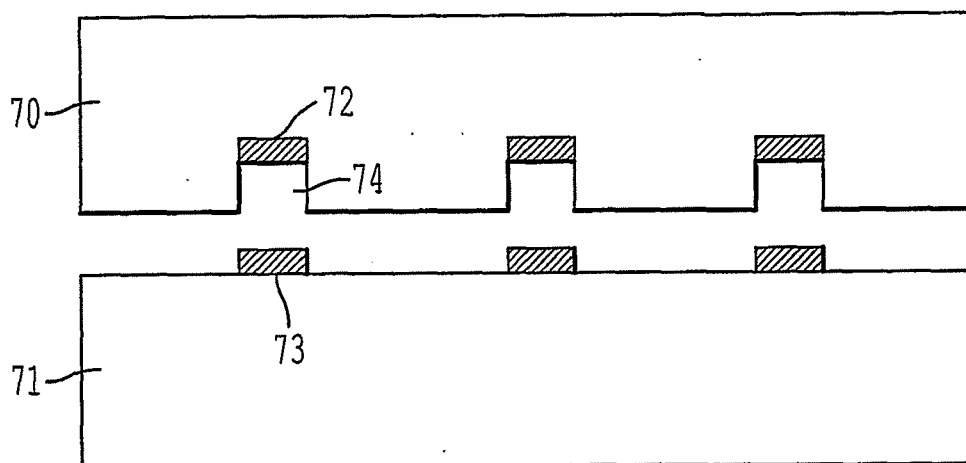
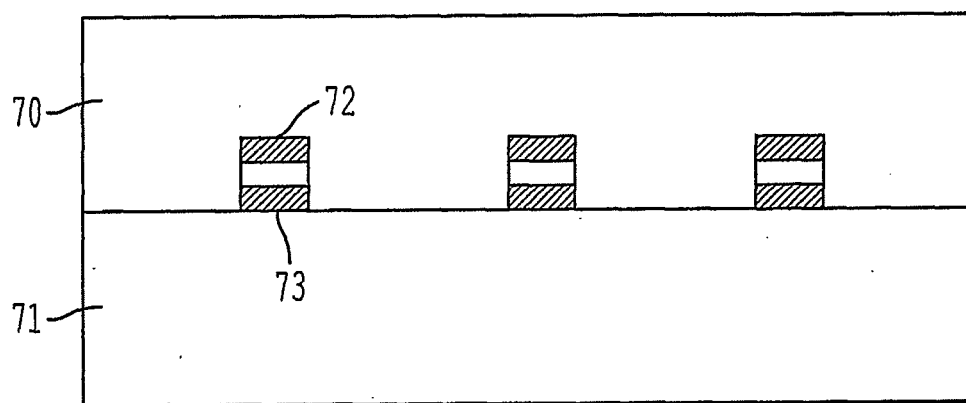
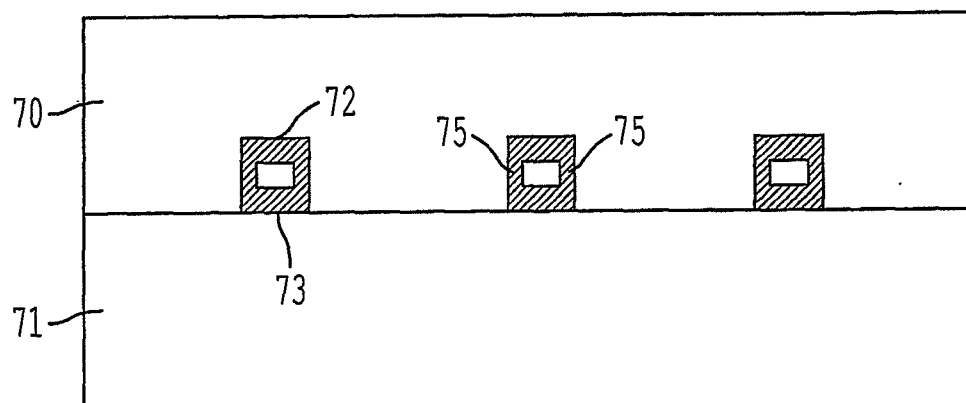


FIG. 7a*FIG. 7b**FIG. 7c*

Plasma Treatment Effect

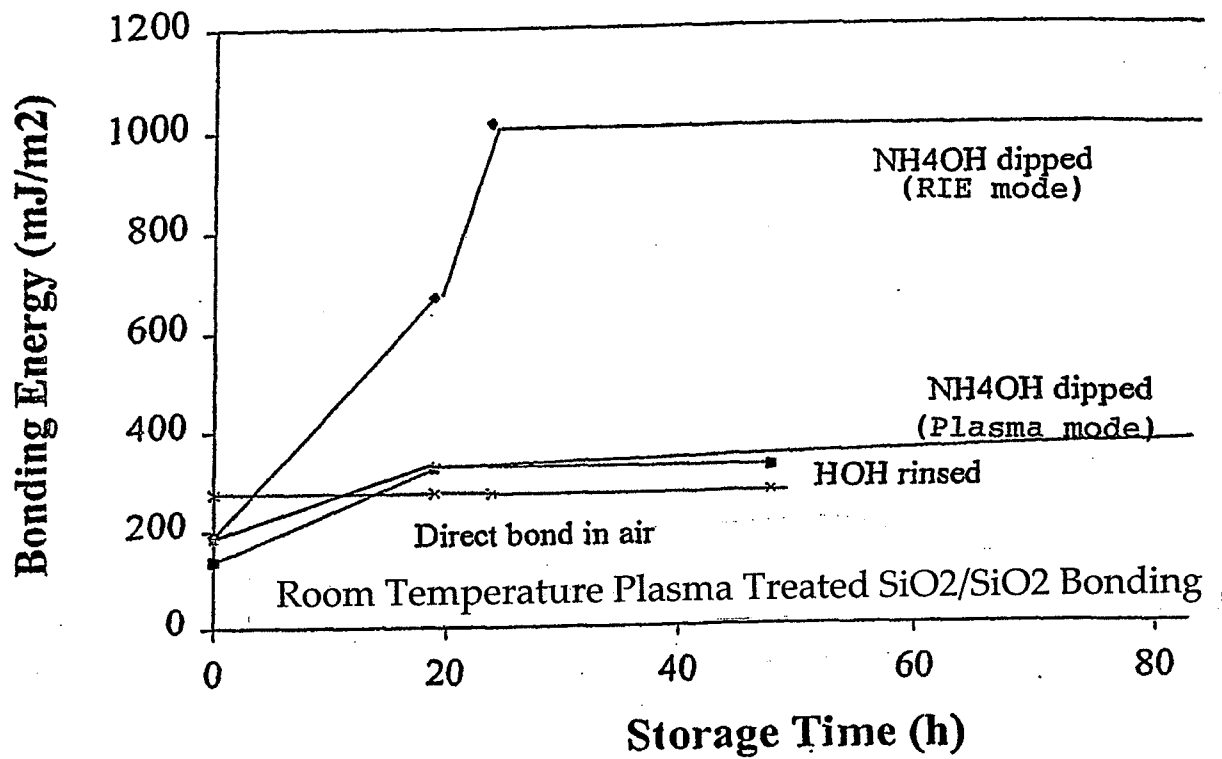


FIG. 8

Room Temperature Si/AlN Bonding

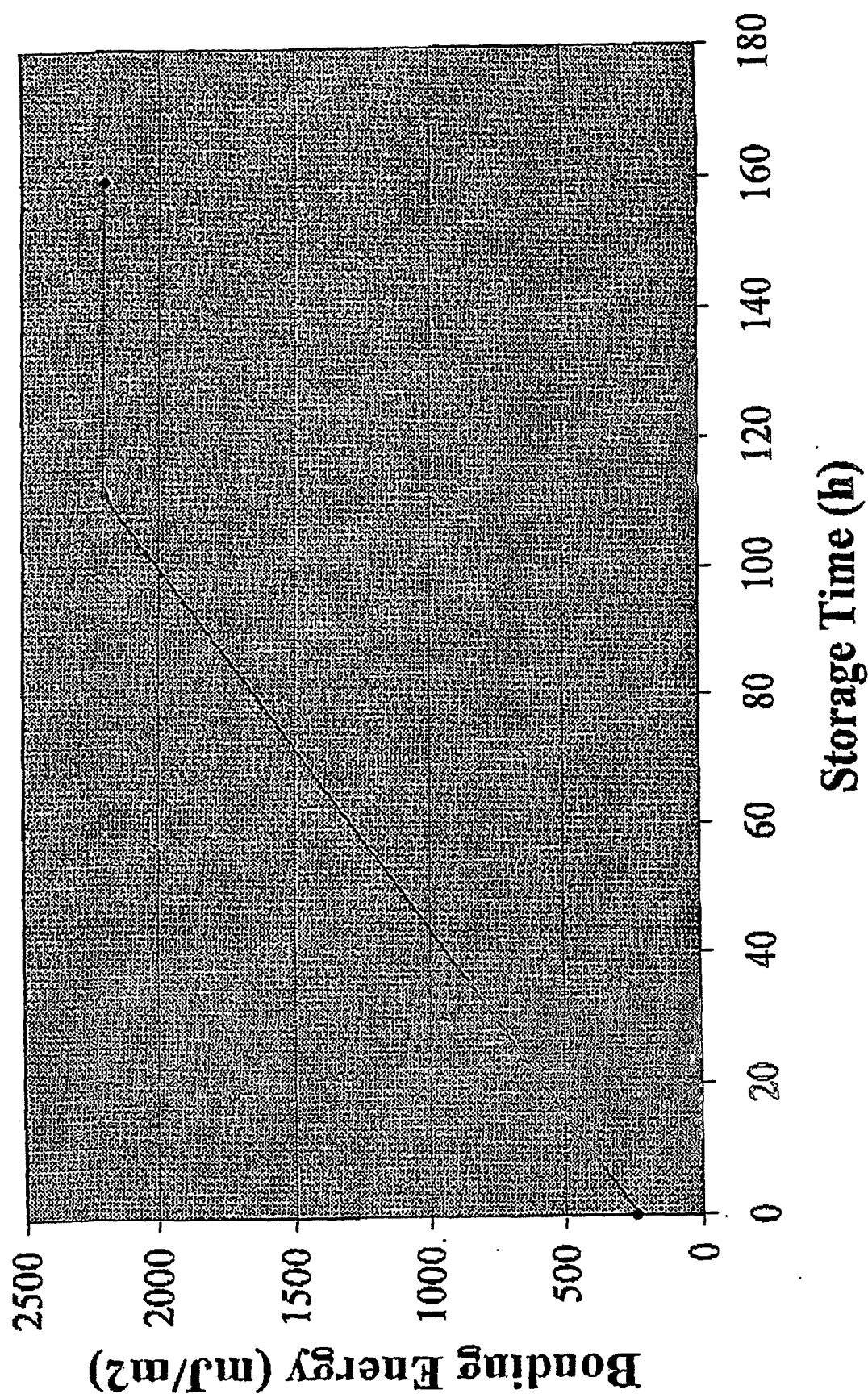


FIG. 9